OPTICAL INTERCONNECTS SYMPOSIUM 2017

The integrated photonics revolution

Jeroen Duis



OUTLINE

- Introduction to SMART Photonics
- Photonic integration
 - Generic platform
 - Applications and examples
 - MPW service
- Processes
- Future developments
- Summary



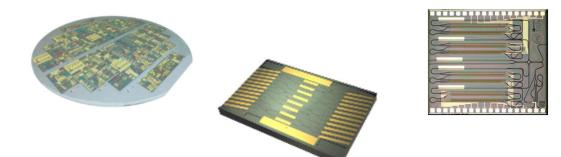
SMART PHOTONICS GENERIC INTEGRATION PLATFORM



OUR HISTORY

SMART Photonics B.V. founded in 2012

1998 20		03 20	09 20	012		
Philips			Philips Research -			
Optoelectronic Center	JDS Uniphase	Cedova	Photonics Lab	SMART Photonics		



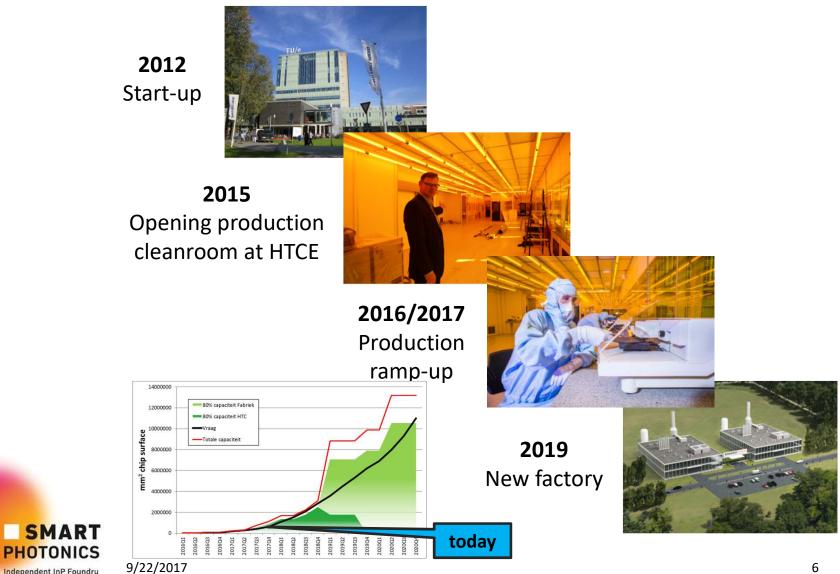


WE OFFER

- Processing services for making photonic components on InP
 - Both discrete and PICs
- Photonic components are used for
 - Tele- and Data communications
 - To meet technology requirements (Gb/s and J/bit)
 - To meet cost requirements (€/ bit and €/mm²)
 - IoT
 - Sensing applications in Medical, Aviation, Automotive, Space, Machining etc.
 - Imaging/ Spectrum analysis etc.



WE ARE MOVING FAST!



Independent InP Foundry

OUR FACILITIES





- SMART Photonics
 @High Tech Campus
 - 570m² 3" Production cleanroom (Class 1000)
 - Processing and epitaxy

- SMART Photonics
 @NanoLab cleanroom Eindhoven
 - 850m² Fully equipped R&D facility



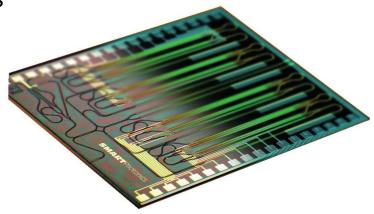
OUR CAPABILITIES

Epitaxy	Multi-wafer MOVPE reactors for base wafer growth, regrowth and overgrowth
Lithography	High throughput, high resolution (>100 nm) - DUV scanner 0.7 μm projection litho – I-Line stepper High resolution (<100 nm) – E-beam 0.6 μm contact litho – contact aligner
Etching	Cassette-based wet etching ICP for single and multi-wafer etching RIE dedicated tools for photoresist, dielectric and polymer etching
Dielectrics	PECVD for SiO _x and SiN _x
Metallization	E-beam evaporation Sputtering Plating
Back-end	Grinding and polishing Scribe and break Optical coatings



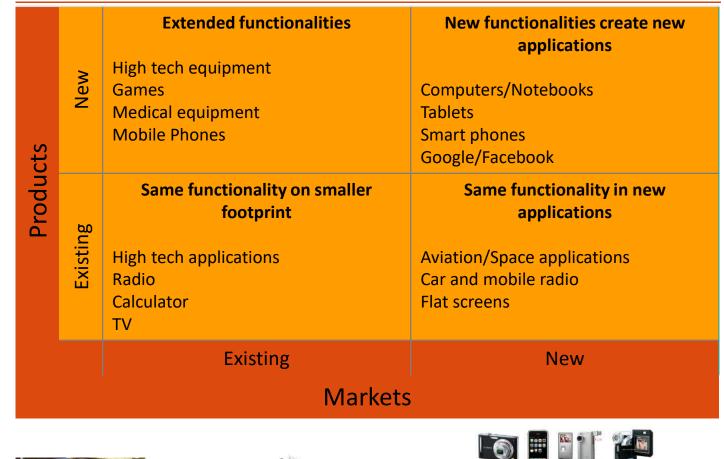
WHAT MAKES US SPECIAL

- People
 - Knowledge and experience in photonics and semiconductor processing
- Capabilities
 - Full process from Epi to coating of facets
 - Unique tools (3" ASML scanner for high resolution litho)
- Proposition
 - Unique PIC technology
 - Buried Hetero DFB process





SEMICONDUCTORS





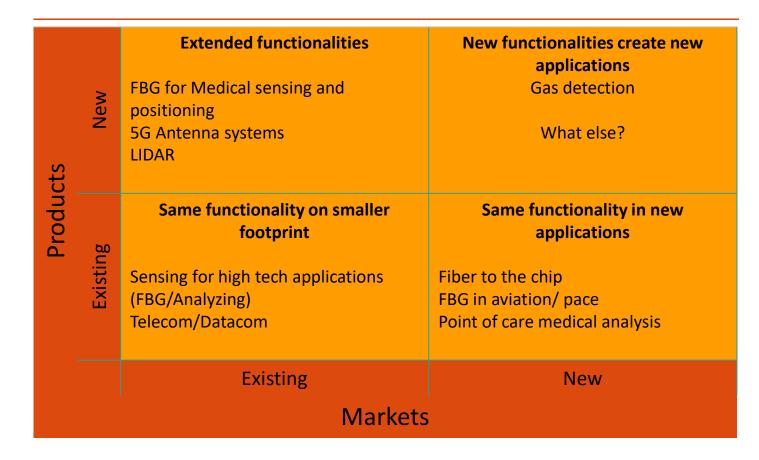


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INP PHOTONICS

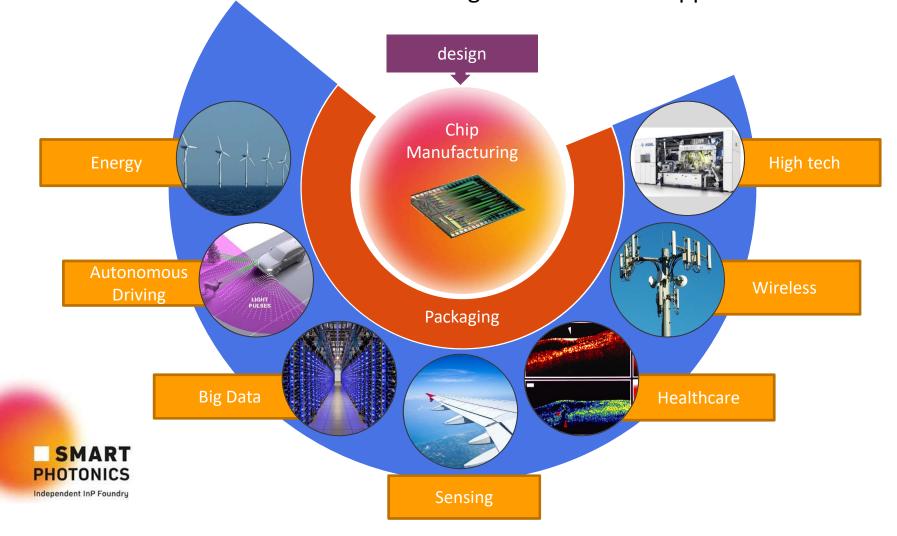




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PHOTONIC INTEGRATION MAKES THE DIFFERENCE!

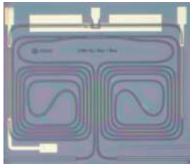
 The SMART Photonics Generic Integration Technology makes the difference enabling a wealth of new applications



GENERIC INTEGRATION PHILOSOPHY

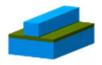
Electronic integration (intel) Соге™ і7 Basic elements:

Photonic integration



Basic elements:

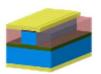










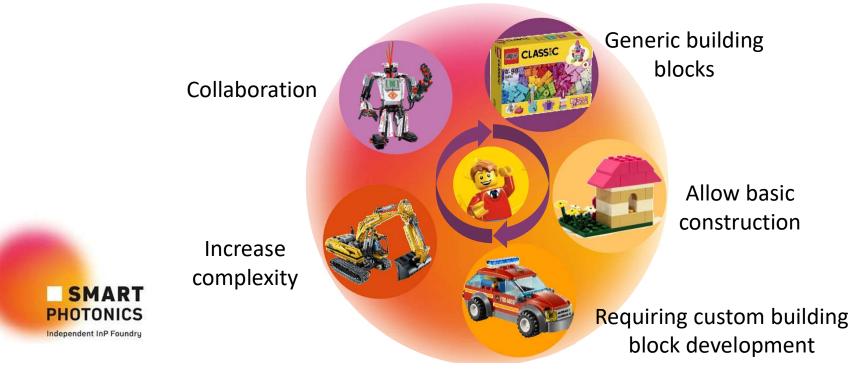




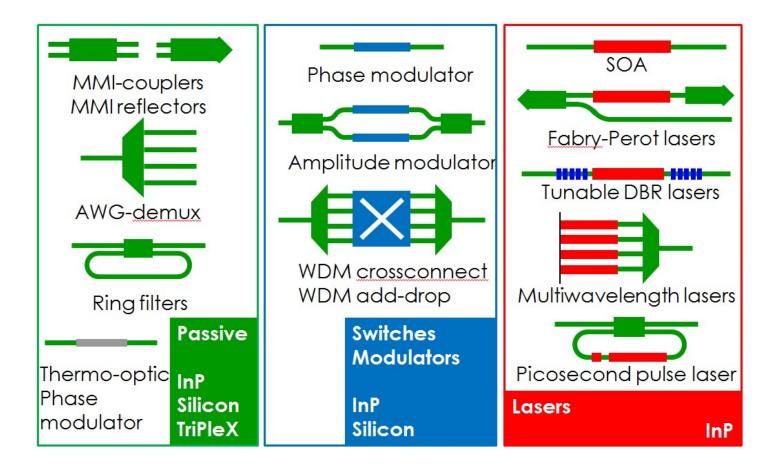
Independent InP Foundry

OUR GENERIC INTEGRATION PLATFORM

- Standardized industrial integration process
- Design on *functional level* by using *building block* approach
- Software design kits for fast and accurate design
- Multi-project wafer (MPW) runs for *fast* and *cost efficient* prototyping
- Enables fast up-scaling to high volume manufacturing

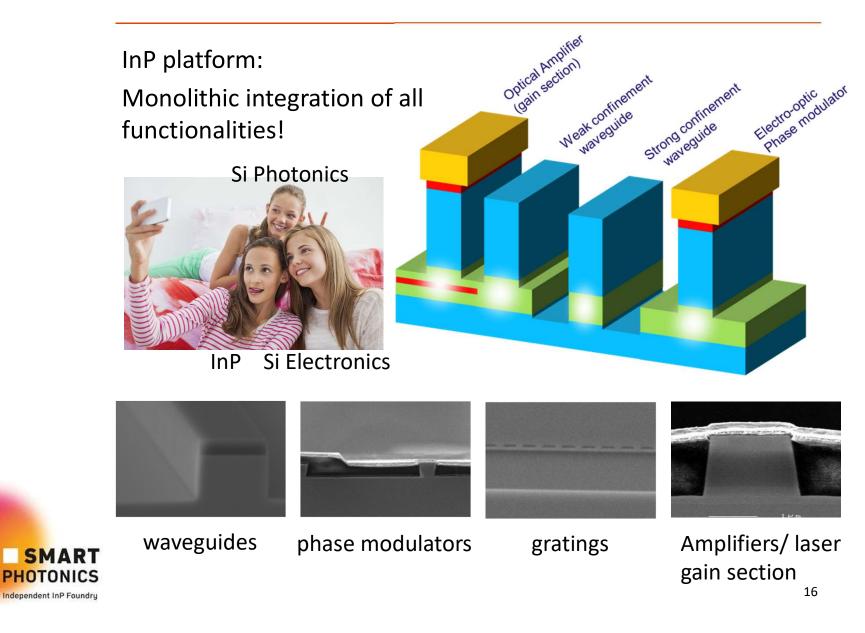


INP PLATFORM CAPABILITIES



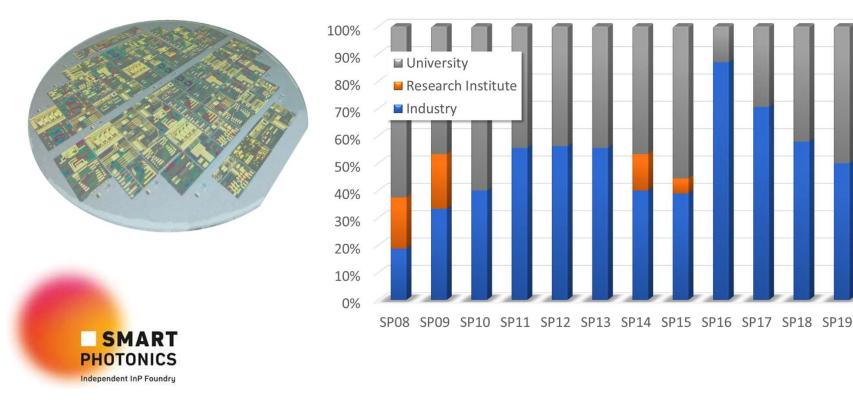


SMART PHOTONICS INTEGRATION PLATFORM



OUR MPW SERVICE

- World's first commercial MPW run on InP in July 2013
- MPW run starts every quarter
- Low threshold access to a new technology
- Over 200 designs fabricated!





PDK: BUILDING BLOCK LIBRARY

- Process Design Kit is available
 - For circuit simulation and mask design
 - Design manual and Functional building block description
 - Full layout-aware design flow
 - Access via state of the art software tools









APPLY NOW FOR THE PHOTONDELTA MPW INNOVATION GRANT

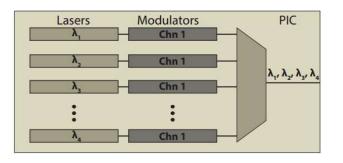
- PhotonDelta, in partnership with <u>JePPix</u> and <u>Brainport</u> <u>Development</u>, is now launching a photonics chip incentive scheme. They are reaching out to help global high-tech companies, large and small, design and build nextgeneration photonics chips specific to their business.
- If you're planning to fabricate your photonics chip with companies in Brabant, you may qualify for a PIC Innovation voucher, worth up to € 4,250.00. This is half the cost of an MPW run
- For more information check <u>www.photondelta.eu</u>

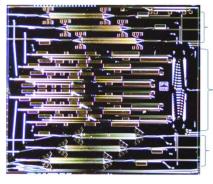




EXAMPLE: 100 GB/S TRANSMITTER

>100 Gb/s transmitter on single chip, fabricated in our powerful MPW platform



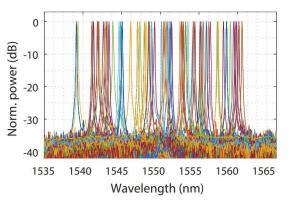


3 x MZM modulator

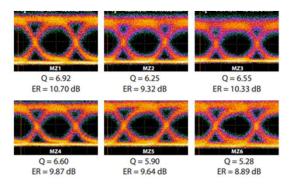
6 x 22 nm tunable laser

3 x MZM modulator

Wavelength tuning



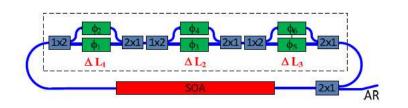
20 Gb/s per channel

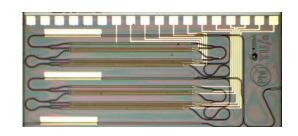


W. Yao, COBRA

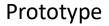


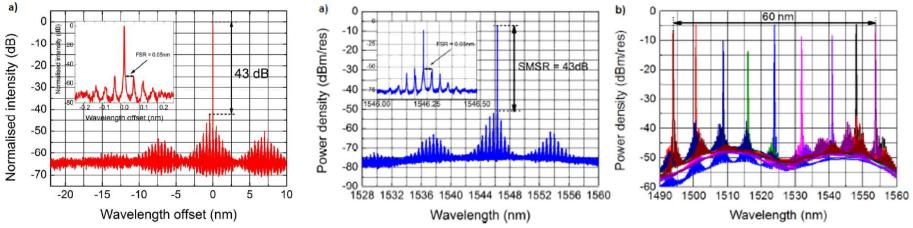
EXAMPLE: WIDELY TUNABLE LASER





Simulations





S. Latkowski, COBRA

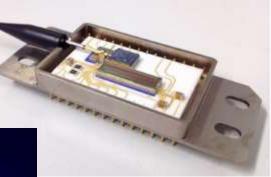
Advanced PDK allowing first-time-right prototyping



EXAMPLE: FBG INTERROGATOR

Distributed temperature and strain measurement with embedded fibers + PIC readouts





Wider possibilities for structural health monitoring



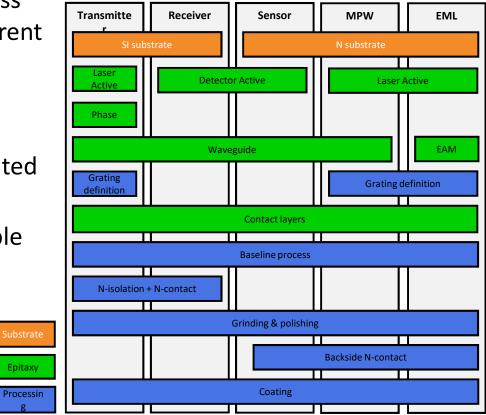


BUILDING BLOCKS



PLATFORM AND CUSTOMIZATION

- Different flavours of the generic process available for different applications
- Up to 3 different materials can be epitaxially integrated
- Customized layerstacks possible

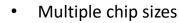




SHORT TERM EXECUTION PLAN FOR MPW

Technologies	2017			2018				
	SP19	SP20	SP21	SP22	SP23	SP24	SP25	SP26
High resolution waveguide definition								
DBR Gratings								
High speed platform 30Ghz performance								
Spot Size Converter								
EAM								
Shipping In Fab Starting Commercial Introduction in M								

- 4 month fab time -> 2 month fab time
 - Doubling number of design iterations per year from 2 to 4
- Scanner implementation -> SP20 -> All time low loss
 - 1,2 dB/cm shallow etch
 - 1,6 dB/cm deep etch
- Increased number of MPW chips from 6 to 8 for same price



SMART PHOTONICS

SUMMARY

- Generic Integration Process available
 - Transmit and receive platform
- Large range of applications demonstrated
- Commercial, low threshold access to technology via quarterly MPW runs for proof of concept
- Industrial scale, production ready process



SMART PHOTONICS

Independent InP Foundry

Meet the experts at booth #495 Contact us: sales@smartphotonics.nl